## Mechanical size effects: Experiments and mechanisms

By

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#### Revision





## Mechanical size effects – why do they occur?

Continuum mechanics (Also thought of as 'bulk' / macro – mechanics)

- Materials are assumed to be devoid of microstructural discontinuities
- Materials can be subdivided into infinitesimal elements with the same properties

#### Property ≠ f (size)

- Several observations revealed that materials behave differently at small length scales, both during intrinsic and extrinsic miniaturization
- Testing materials at the desired length scales using conventional testing methods Miniaturization!

## Motivation: Why study size effects?



Fundamental changes in material's mechanical response observed with:

1. Decreasing internal microstructural length scale (intrinsic)



2. Decreasing external dimensions of devices and applications (extrinsic)



issue phase

## Motivation: Age of miniaturisation



Nanostructured materials have potential applications as :

- Builiding block for electronic devices like silicon nanowires in integrated circuits (mech. integrity, carrier mobilities under strain)
- ZnO nanowires in "nanogenerators"
  (bending strength, piezoelectric properties)
- Building blocks in nanoelectromechanical systems Magnetic nanowires for the artificial nose/ear projects
- End-effectors for scanning probe tips
   (tip-enhanced Raman spectroscopy, high-aspect ratio tips)

## Motivation: Why study size effects?



Academic: To discern fundamental material behavior, which is increasingly being seen to be different at smaller length scales. Macroscopic single crystals in sizes that are suitable for conventional testing techniques are difficult to process or unaffordable.

#### □ Industrial:

- Nanomaterials (with awesome properties) are impossibly difficult to obtain in bulk form currently. They have to be studied at the smallscale in free-standing or thin film form.
- Increasing device miniaturisation in the micro-electro-mechanical space routinely uses wafers and thin films, whose performance is directly connected to their behavior at these length scales

#### Size effect (extrinsic): decreasing specimen dimension

#### DBTT due to sample size

Si (100) Increasing pillar diameter





## Device miniaturization and its sid(z)e effects



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DelRio et al., Appl Phy Rev, 2015 1

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#### Size effect (intrinsic): Macro to meso to micro structure

#### Structural material: Natural: Bone



#### Size effect: Change in deformation mechanism

# Strengthening mechanisms observed in bulk materials

- Dislocation source activation and multiplication
- Precipitation hardening
- Solid solution strengthening
- Grain boundary strengthening

In general: Strength increases Ductility decreases Fracture toughness remains constant

# Nanostructured materials (geometry/microstructure)

- Sputtering
- Evaporation
- Electrodeposition
- Severe plastic deformation





## Methods: From macro to micro-mechanics

#### **Tension-compression**

#### Instron UTM

- Sample size ~100mmX10mmX10mm
- Load range
   0 to 5kN-500kN
- Load resolution
   (1/1000 of load cell) ~5N
- Displacement range 0 to 100mm-150mm
- Displacement rate
   1 to 5e5 μm/min

#### http://www.instron.com/enus/products/testingsystems/universal-testingsystems/electromechanical



#### Kamrath and Weiss

- Sample size
   60 mm X 10 mm X 3mm
- Load range 0 to 5kN
- Load resolution 0.2N
- Displacement range +/- 10mm
- Displacement rate
   6 to 1200 μm/min

http://www.kammrathweiss.com/en/products/m aterials/tensilecompression.html



#### Nano Tensile

- Sample size
- Load range 0 to 150mN - 10N
- Load resolution 10nN - 1μN
- Displacement range
   0 to 80μm 150mm
- Displacement resolution
   0.02 nm 100nm
- Displacement rate 0.1 to 20 μm/s

Hysitron nanoTensile 5000 sell sheet



## Methods: Small-scale mechanical testing



Hysitron Inc, USA

## Methods: Testing techniques for deformation

#### Indentation



#### **Compression Testing**



#### **Tensile Testing**



#### **Bending Experiments**



#### **MEMS** based Testing



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B. N. Jaya and V. Jayaram, Current Science, 2013 15

#### Methods: Testing techniques for fracture











5 µm



## Methods: Specimen preparation



#### Lithography





4) Exposure





3) Prebake



7) Hardbake

8) Etching

9) Stripping





http://www.wias-berlin.de/

#### Methods: Specimen preparation







FIBtec.html

## Methods: Specimen preparation



#### FIB micromachining: Site specific



Volkert and Minor MRS Bulletin 32 (2007) 389



Kiener et al., Materials Science and Engineering A 505 (2009) 79–87



#### Nanoindentation

Mechanical probing of a material surface to nm-scale depths, while simultaneously monitoring LOAD and DEPTH.



DISPLACEMENT, h



https://www.youtube.com/watch?v=AEatCyb1t-A

- Flat specimen polished
   (Film low surface roughness)
- Small volumes of material
- Large plastic strains can be applied

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Oliver and Pharr, J. Mater. Res. 7 (1992) 1564



#### **Micro compression-tension**



#### **Micro compression-tension**



- Constant deformation volume
- Pre-defined volume before and after deformation, and in situ testing
- Straight forward stress-strain analysis:



Uchic et al. Science 305 (2004) 986.

As compared to indentation testing





#### Microbeam bending and fracture:



#### Dehm et. al, Adv Eng Mater, 2006

Jaya et. al, Phil Mag, 2012

## Methods: Effect of test geometry





W h a 2d 10 μm

$$K_I = \sqrt{3} \frac{(e - \mu h)}{bd^{3/2}} F_{max}$$



$$K_c = \frac{\gamma F_{max}}{R^{3/2}}$$

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B. N. Jaya et al, JMR, 201524

## Methods: Effect of test geometry







a) Single cantilever bend K<sub>IC</sub> (MPam<sup>1/2</sup>): 0.76±0.08

b) Clamped beam bend K<sub>IC</sub> (MPam<sup>1/2</sup>): 0.81±0.10

c) Double cantilever compression K<sub>IC</sub> (MPam<sup>1/2</sup>): 0.89±0.12

d) **Pillar split** K<sub>IC</sub> (MPam<sup>1/2</sup>): **0.75±0.016**\*



d (nm)



Sample preparation: Ion damage effects (FIB)





#### Sample testing: Indentation

- Pile-up, sink-in corrections
- Tip rounding and tip area calibration
- Substrate compliance
- Thermal drift
- Surface roughness





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Pharr et al. Annu. Rev. Mater. Res. 40 (2010) 27127

#### Sample testing: Micro-compression



#### Sample testing: Alignment in tension

160

140

tensile stress [MPa] 00 001 09 001

40

20

0

n

**3°** 

0.002



oure tension

0.008

at 0.9% strain

0.01

.5° at 0.9% strain .75° at 0.9% strain • Sufficient stiffness of all involved parts (like copper needle or tungsten gripper)

Kiener et al., Acta Materialia 56 (2008) 580-592

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tensile strain [-]

0.006

0.004

misaliğnm

#### Effect of test geometry

Prediction (MPa m <sup>1/2</sup> )	Measurement (MPa m <sup>1/2</sup> )	Test method <sup>a</sup>	Reference
$T_{(111)} = 0.72$	0.65 <sup>b</sup>	DCB, $E = 168$ GPa	34
()	0.65 <sup>b</sup>	DCB, $E = 168$ GPa	35
	0.937	T-DCB	36
	1.0	DT	38
	0.9	T-DCB	37
$0.73 < T_{(110)} < 0.80$	0.74 <sup>b</sup>	DT, $M = 150$ GPa	39
(110)	0.72	DCB	41
	0.65	SECB	43
	0.71	SECB	44
	0.95	SECB	45
	0.84	COD	42
$T_{(\text{poly})} \approx 0.80$	1.1	SECB	46
	0.81	SECB	47
	1.0	SECB	48 and 49

#### Single and polycrystalline Si

DelRio et al., Appl Phy Rev, 2015

#### Cementitious material



C. Ouyang and S.P. Shah, J. Amer. Ceram. Soc., 1991

#### Results and Discussion:





#### Extrinsic size effects: Plane stress vs strain





## Extrinsic size effects: Plane stress vs strain





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Kang et al, Exp Mech 2005

## Extrinsic size effects: Effect of surface





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Dong II Son, Key Eng Mater, 2005

## Extrinsic size effects: Effect of surface



#### Effect of thin film thickness



## Extrinsic size effects: Indentation size effect







Density of geometrically necessary dislocations:

$$\rho_g = \frac{3h}{2ba^2} = \frac{3}{2} \frac{\tan^2 \theta}{bh}$$

X. Hou et al., J Appl Phy, 2013

#### Extrinsic size effects: GNDs and strain gradient plasticity





(c)





Fig. 1. Plastic strain gradients are caused by the geometry of deformation (a, b), by local boundary conditions (c, d) or by the microstructure itself (e, f).



## Extrinsic-Intrinsic borderline: No microstructure

Amorphous structures: Metallic glasses



#### Add microstructre

Ductile materials: FCC metals: Smaller is stronger, universal relationship



Semi-Ductile materials: BCC metals: Smaller is stronger but no universal relationship



#### Dislocation starvation vs dislocation source truncation

Greer and Nix, PRB, 2006

#### Intrinsic size effects





#### Intrinsic size effects: Effect of grain size





#### Intrinsic size effects: Effect of grain size



## Intrinsic size effects: Effect of grain size



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#### Intrinsic size effects: Poly-crystals



(Inverse) Hall-Petch



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Arzt., Acta Mat, 1998

#### Intrinsic size effects: Poly-crystals





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Mohamed et al., Met Trans, 2010

#### Intrinsic size effects: Effect of microstructure

Fracture toughness of polycrystalline materials



## Intrinsic size effects: Multilayers-interface effects



## Intrinsic size effects: Multilayers-interface effects

Confined layer slip



#### Intrinsic size effects: Architectured interface





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Sen and Buehler, Scientific reports, 2011

## Case study I: NiAl bond coats











#### Complex, heterogeneous microstructure with 4 distinct zones



220	Coating	Substrate -70	0 10 -		Coating	Substrate	- 70	
220 -			) 9-	I	M	MA	- 60	
200 -		- 50	) -	Ā	www.ylyT f		- 50	
- 001 a)			(at%) GPa)				- 40 (%) (at%)	
ш 180- 170		-30	ŢŢŢŢ				- 30 <sup>Ξ</sup>	
170 - 160 -		- 20	6-	MA			- 20	
150 -		- 10	5 -	1		ŢŢŢŢŢŢŢ	- 10	
0 20 40 60 80 100 120 140 160 180			+					
Distance (microns)				Distance (microns)				
			]	Micro	-scale frac	cture	K <sub>IC</sub> / bulk	
			$]$ $K_{\rm IC}/L$	Micro EFM	-scale frac K <sub>IC</sub> / EPFM	cture K <sub>IC</sub> / CTOD	K <sub>IC</sub> / bulk	
NiAl s	oft [110]		$K_{\rm IC}/L$	Micro efm	-scale frac K <sub>IC</sub> / EPFM 3.5 <sup>2</sup>	ture K <sub>IC</sub> / CTOD 1.8 <sup>2</sup>	K <sub>IC</sub> / bulk 1.8-4.5 <sup>3</sup>	
NiAl s NiAl h	oft [110] nard [100]			Micro efm	-scale frac $K_{IC}/$ EPFM $3.5^2$ $8.6^2$	ture $K_{IC}/_{CTOD}$ $1.8^2$ $7.9^2$	K <sub>IC</sub> / bulk 1.8-4.5 <sup>3</sup> 6.9 <sup>3</sup>	
NiAl s NiAl h NiAl b	oft [110] hard [100] bond coat (low	Al activity)		Micro efm	-scale frac $K_{IC}/$ EPFM $3.5^2$ $8.6^2$ N.A	ture $K_{IC}/_{CTOD}$ $1.8^2$ $7.9^2$ N.A	K <sub>IC</sub> / bulk 1.8-4.5 <sup>3</sup> 6.9 <sup>3</sup> N.A	

[1] F. Iqbal, Ast, M. Goeken and K. Durst, Acta. Mater. 60, 1193 (2012).

2] J. Aston Przybilla, V. Maier, K Durst and M. Goeken, J. Mater Res. 29, 2129 (2014).

13 . B. Miracle, Acta. Metall. Mater. 41, 649, (1993).

4] R. Webler, M⊖Krottenthaler, S. Neumeier, K. Durst and M. Göken, Int. Symp. Superalloys, 93 (2012).

Max-Planck-Institut für Eisenforschung, Düsseldorf, Germany ayaram, Phil. Mag, (2015).

Pop-in load/change in compliance correlated with crack initiation or propagation event





micro / nano mechanics Max-Planck-Institut für Eisenforschung, Düsseldorf, Germany

Jaya et. al, Phil Mag, 2012

Fracture toughness as a function of matrix stoichiometry









Toughening mechanisms in individual zones at the micron-scale





What did we learn? :

micro / nano mechanics

- Intrinsic fracture toughness  $K_{IC}$  increases with Ni:AI ratio across the bond coat
- Crack closure and rising fracture toughness seen at micron-length scales
- Toughening mechanisms vary depending on the zone.





- •There is no universal size effect across all length scales and all material systems
- •Each material property responds differently to length scale effects
- •There is a need to study each material system at the length scale regime at which it is applicable (designed for service)

# Thank you for your attention!!

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